IE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

FEB 0 2 2004

Kulbinder K. Banger et al.

Title:

SINGLE SOURCE PRECURSORS FOR TERNARY

CHALCOPYRITE MATERIALS, AND METHODS OF MAKING AND

USING THE SAME

Serial No.:

10/698,118

Art Unit: not yet assigned

Filed:

October 31, 2003

Examiner:

not yet assigned

Docket:

35089US1

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.98, applicant is submitting herewith Form PTO-1449 listing references for consideration by the Examiner. Also submitted herewith is a legible copy of each reference listed.

If any further fees are required by this communication, please charge such fees to our Deposit Account No. 16-0820, Order No. 35089US1.

> Respectfully submitted, PEARNE & GORDON LLP

Steven J. Solomon, Reg. No. 48719

1801 East 9th Street, Ste. 1200 Cleveland, Ohio 44114-3108

(216) 579-1700

I hereby certify that the attached correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

> Steven J. Solomon Name of Depositor for Applicant(s)

January

Signature of Depositor

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(USE SEVERAL SHEETS IF NECESSARY)

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	OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)											
	E		Contreas, M., et al., "Progress Toward 20% Efficiency in Cu(In,Ga)Se2 Polycrystalline Thin-Film Solar Cells", <i>Prog. Photovolt. Res. App.</i> , 1999, 7, pgs. 311-316.									
	F		Hoffman, D., et al., "Thin-Film Solar Array Earth-Orbit Mission Applicability Assessment", XVII Space Photovoltaic Research and Tech. Conf., 2001.									
	G	Bailey, S.G., et al.	, "Space Pho	otovoltaics", <i>Prog. Pl</i>	hotovolt. Re	es. App., 1	998, 6,	1-14.				
•	Н			ment of CIS Solar C Energy Conf., Viens			ations",	Eds.	Schmid, J., et			
	I			fultinary Solar Cells ence, 1993, ABSTR		duInSe <sub>2</sub> ", I	Proc. 23	Prd IEE	EE			
	J		Basol, B.M., et al., "Cu(In,Ga)Se <sub>2</sub> Thin Films and Solar Cells Prepared by Selenization of Metallic Precursors", J. of Vacuum Science and Technology A, 1996, 14A, pgs. 2251-2256.									
	K		Probst, V., et al., "Rapid CIS-Process for High Efficiency PV-Modules: Development Towards Large Area Processing", <i>Thin Solid Films</i> , 2001, 387, pgs. 262-267.									
	L	• •	•	y and Pilot Operation 1998, 6, pgs. 193-199.		Cells of Cu	InSe₂ a	nd Th	eir Alloys",			
Examiner	:			D	ate Consid	ered						
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	E			of CuInSe <sub>2</sub> Films and ounds", Sol. Energy									
	F			ation and Componer id Films, 2001, 387,			Proce	esses i	n Elec	ctrodeposite			
	G			Film CIS Alloy PV N Thin Solid Films, 200				ing No	on-Va	cuum,			
	Н	Klenk, M., et al., Thin Solid Films,	•	f Flash Evaporated C gs. 47-49.	Chalcopyrit	e Abso	orber I	Films	and S	olar Cells",			
	I Dzionk, C., et al., "Phase Formation During the Reactive Annealing of Cu-In Films in H₂S Atmosphere", <i>Thin Solid Films</i> , 1997, 299, pgs. 38-44.									n H₂S			
	J	Krunks, M., et al., Thin Solid Films,		on and Structure of C pgs. 61-64.	CuInS <sub>2</sub> Film	ns Prej	pared	by Spr	ray Py	rolysis",			
	K	Artaud, M.C., et a Thin Solid Films,		Thin Films Grown b gs. 115-123.	y MOCVE	Cha	racter	izatio	n, Fir	st Devices",			
	L	Jones, A.C., et al., Application", VCF		ompound Semicondu 7, pgs. 42-99.	ctors: Pre	cursors	Syntl	hesis,	Deve	opment &			
	М	Nomura, R., et al.,	, "Preparation	n of Copper-Indium-	Sulfide Th	in Film	ns by	Soluti	on Py	rolysis of			

Examiner:

Date Considered

\*Examiner:

Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Organometallic Sources", Chem. Let., 1988, pgs. 1849-1850.

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## U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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UNIT: not yet assigned October 31, 2003 U.S. PATENT DOCUMENTS Filing Date If Examiner Class Subclass Document No. Date Name Appropriate Initial A В C FOREIGN PATENT DOCUMENTS **Subclass** Translation Country Class Document No. Date D OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.) Nomura, R., et al., "Oxygen-or Sulphur-Containing Organoindium Compounds for Precursors of Ε Indium Oxide and Sulphide Thin Films", Polyhedron, 1990, 9, pgs. 361-366. Nomura, R., et al., "Preparation of CuInS2 Thin Films by Single-Source MOCVD Process Using F Bu<sub>2</sub>In(SPr)Cu(S<sub>2</sub>CNPri<sub>2</sub>)", J. Mater. Chem., 1992, pgs. 765-766. Nomura, R., et al., "Preparation of CuIn, S<sub>8</sub> Thin Films by Single-Source Organometallic Chemical G Vapour Deposition", Thin Solid Films, 1992, 209, pgs. 145-147. Hirpo, W., et al., "Synthesis of Mixed Copper-Indium Chalcogenolates. Single Source Precursors Н for the Photovoltaic Material CuInQ<sub>2</sub> (Q = S, Se), J. Am. Chem. Soc., 1993, 115, pgs. 1597-1599. Hollingsworth, J.A., et al., "Spray CVD of Copper Indium Disulfide Films: Control of I Microstructure and Crystallographic Orientation", Chem. Vap. Deposition, 1999, 5, pgs. 105-108. Hollingsworth, J.A., et al., "Spray Chemical Vapor Deposition of CuInS<sub>2</sub> Thin Films for J Application in Solar Cell Devices", Mat. Res. Soc. Symp. Proc., 1998, 495, ABSTRACT. Harris, J.D., et al., "Using Single Source Precursors and Spray Chemical Vapor Deposition to Κ Grow Thin-Film CuInS<sub>2</sub>", Proc. of the 28th IEEE Photovoltaic Specialists Conference, 2000, **ABSTRACT** Banger, Kulbinder K., et al., "Synthesis and Characterization of the First Liquid Single-Source L Precursors for the Deposition of Ternary Chalcopyrite (CuInS<sub>2</sub>) Thin Film Materials", Chem. Mater., 2001, 13(11), pgs. 3827-3829. Examiner: Date Considered \*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		OTHER REFER	ENCES (Inc	cluding Author, Ti	tle, L	Date, Pe	rtinei	nt Pag	es, Etc	c.)			
	Е	Hollingsworth, J.A. Semiconductors",			-		Thin	-Film	III-V	and 1	I-III-VI		
	F	Drago, R.S., et al., to Understand Cob									se of E and C		
	G	Riga, A. et al., "Pr Chemical Vapor D Conference on The	eposition Aid	led by Thermal A	ıalyti	cal Tecl	hniqu						
	Н	Hollingsworth, J.A Cells Via Spray C							·III-VI	2 Thi	n-Film Solar		
	I	Chalcopyrite Mate	Banger, K.K., et al., "A Review of Single Source Precursors for the Deposition of Ternary Chalcopyrite Materials", NASA Conference Publication (2002), (17th Space Photovoltaic Research and Technology Conference, 2001), pgs. 115-125.										
	J	J Deivaraj, T.C., et al., "Novel Bimetallic Thiocarboxylate Compounds as Single-Source Precursors to Binary and Ternary Metal Sulfide Materials", <i>Chemistry of Materials</i> , 2003, 15(12), pgs. 2383-2391.											
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	Е			ulnS2 Prepared by E Photovoltaic Spec								
	F			ach Towards the D Proceedings, 2002,			I-VI Th	in Filr	ms", <i>M</i>	<i>laterials</i>		
	G			Single-Source Precedence Chemistry, 2002,				ne Thir	n-Film	Solar		
	Н	Characterization of	Banger, K.K., et al., "Facile Modulation of Single Source Precursors: The Synthesis and Characterization of Single Source Precursors for Deposition of Ternary Chalcopyrite Materials", <i>Thin Solid Films</i> , 2002, 403-404, 390-395.									
	I	•		Source Precursors to 01, 22, pgs. 2304-2	-	y Silver	Indiun	ı Sulfi	de Ma	terials",		
	J	Low-Temperature	Banger, Kulbinder K., et al., "Facile Modulation and Preparation of Single Source Precursors for Low-Temperature Deposition of Ternary Chalcopyrite Materials", Abstracts of Papers, 222 <sup>nd</sup> ACS National Meeting, August 26-30, 2001, American Chemical Society, ABSTRACT.									
	K			s and Structure of 2002, pgs. 111-11		\g(μ-Cl	)(μ-SC	{O} Ph	n)In(S	C{O}Ph)2]",		
Examiner: Date Considered												

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	E			zation of CulnS2 Fi Materials Science &								
	F	Deposited on Sap LiNb0.5Ta0.5O3	Shibata, J., et al., "Transmission Electron Microscopic Studies of LiNb0.5Ta0.5O3 Films Deposited on Sapphire Substrates by Thermal Plasma Spray CVD (Microstructure of LiNb0.5Ta0.5O3 Films Deposited by Thermal Plasma Spray CVD)", Materials Transactions, 2002, 43(7), ABSTRACT.									
	G	Henderson, D., "C Materials & Desi	•	ructural Characteri 7), pgs. 585-589.	zation	of Co	pper	Indiu	m Dis	ulfide	Thin Films",	
	H Vittal, J.J., et al., "Group 11 and 13 Metal Thiocarboxylate Compounds as Single Source Molecular Precursor for Bulk Metal Sulfide Materials and Thin Films", Progress in Crystal Growth and Characterization of Materials, 2002, pgs. 21-27.											
	Jin, M.H.C., et al., "The Effect of Film Composition on the Texture and Grain Size of CuInS <sub>2</sub> Prepared by Chemical Spray Pyrolysis", <i>Mat. Res. Soc. Symp. Proc.</i> , Vol. 763, 2003, pgs. B8.23. B8.23.6.											
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Examiner: Date Considered												
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